



IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

Patent Application

Inventors: R.T. Aiken

J. Huang

Case: 5-11

Serial No.: 09/672512

Group Art Unit: 2686

Filed: 9/28/00

Examiner: Roberts P. Culbert

Title: Method of Etching Ferroelectric Material

RECEIVED

FEB 09 2004

Technology Center 2600

COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

REQUEST FOR RECONSIDERATION

In response to the Office Action dated September 30, 2003, please amend the above-identified application as follows:

- Remarks begin on page 2 of this paper

Date of Deposit	January 30, 2004
I hereby certify that this correspondence is being deposited with the United States Postal Service in a First Class Mail envelope on the date indicated above and is addressed to:	
Mail Stop	Amendment
Commissioner for Patents	
P.O. Box 1450	
Alexandria, VA 22313-1450.	
Catherine F. Dugan	
Printed name of person mailing paper or file	
Catherine F. Dugan	
Signature of person mailing paper or file	